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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/700,557	11/05/2003	David Wu	50432-367	7469
7590 10/05/2004			EXAMINER	
	T, WILL & EMERY		PICARDAT, KEVIN M	
600 13th Street, N.W. Washington, DC 20005-3096			ART UNIT	PAPER NUMBER
washington, E	20003-3070		2822	

DATE MAILED: 10/05/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

			Are
	Application No.	Applicant(s)	<del>- \                                   </del>
	10/700,557	WU ET AL.	
Office Action Summary	Examiner	Art Unit	
	Kevin M. Picardat	2822	
The MAILING DATE of this communication appeariod for Reply	ppears on the cover sheet w	ith the correspondence address	
A SHORTENED STATUTORY PERIOD FOR REP THE MAILING DATE OF THIS COMMUNICATION  - Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a re - If NO period for reply is specified above, the maximum statutory perio  - Failure to reply within the set or extended period for reply will, by statu.  Any reply received by the Office later than three months after the mail earned patent term adjustment. See 37 CFR 1.704(b).	I.  1.136(a). In no event, however, may a seply within the statutory minimum of thing will apply and will expire SIX (6) MOI ute, cause the application to become A	reply be timely filed  ty (30) days will be considered timely.  NTHS from the mailing date of this communicat  BANDONED (35 U.S.C. § 133).	ion.
Status			
1) Responsive to communication(s) filed on <u>05</u>	November 2003.		
2a) This action is <b>FINAL</b> . 2b) ⊠ Th	nis action is non-final.		
3) Since this application is in condition for allow	ance except for formal mat	ters, prosecution as to the merits	is
closed in accordance with the practice under	Ex parte Quayle, 1935 C.I	D. 11, 453 O.G. 213.	
Disposition of Claims			
4) Claim(s) 1-20 is/are pending in the application	n.		
4a) Of the above claim(s) is/are withdr	rawn from consideration.		
5) Claim(s) is/are allowed.			
6) Claim(s) <u>1-20</u> is/are rejected.			
7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and	or election requirement		
	or election requirement.		
Application Papers			
9) The specification is objected to by the Examir		7	
10) The drawing(s) filed on <u>05 November 2003</u> is			
Applicant may not request that any objection to the Replacement drawing sheet(s) including the corre			(4)
11) The oath or declaration is objected to by the B	·	• • •	• •
,		d 011100 / (011011 01 10111 1 1 0 1 1 0 2 .	
Priority under 35 U.S.C. § 119			
<ul> <li>12) ☐ Acknowledgment is made of a claim for foreig</li> <li>a) ☐ All b) ☐ Some * c) ☐ None of:</li> <li>1.☐ Certified copies of the priority document</li> </ul>	nts have been received.		
2. Certified copies of the priority docume	·	<del></del>	
<ol> <li>Copies of the certified copies of the pri application from the International Bure</li> </ol>	•	received in this National Stage	
* See the attached detailed Office action for a list	st of the certified copies not	received.	
Attachment(s)			
1) X Notice of References Cited (PTO-892)	4) Interview	Summary (PTO-413)	
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No	s)/Mail Date nformal Patent Application (PTO-152)	
<ol> <li>Information Disclosure Statement(s) (PTO-1449 or PTO/SB/0: Paper No(s)/Mail Date <u>11-05-03</u>.</li> </ol>	8) 5) Notice of Other:		

## **DETAILED ACTION**

## Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1-20 are rejected under 35 U.S.C. 102(e) as being anticipated by Lo et al. US 6,791,155.

Lo et al. discloses a process of forming a shallow trench isolation including providing a substrate (100), forming a trench (105) in the substrate, depositing at least two insulating layers into the trench to form a STI structure, wherein an innermost of the insulating layers (130) substantially conforms to the base and the side walls of the trench and an outermost of the insulating layer (140) spans the side walls of the trench so a gap is formed in the trench, and planarizing the insulating layer (see figs. 1-4 and related text). Also disclosed is that the gap may be a vacuum or contain air, the insulating material may be silicon dioxide and the gap is sealed. Also Lo et al. discloses that various materials and dimensions may be used in forming the STI, and that various known semiconductor processing steps may be preformed before or after the formation of the STI. Lo et al. teaches that the STI structure is formed on a semiconductor substrate and it is well known that a silicon on insulator is a semiconductor substrate.

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The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kevin M. Picardat whose telephone number is 571-272-1841. The examiner can normally be reached on Monday-Thursday 7:00-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on 571-272-1852. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Kevin M. Picardat Primary Examiner Art Unit 2822

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